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21283/931A 3750 PCT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

ZHENGHE HAN et al.

Serial No: 10/541,296

Filed: July 6, 2005

For: SURFACE MODIFICATION  
METHOD IN FABRICATING HIGH  
TEMPERATURE SUPER  
CONDUCTIVE DEVICES

Art Unit: 1793

Examiner: Paul A. Wartalowicz

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

Dear Sir:

In response to the Office Action dated July 24, 2008, please amend the above identified application as follows:

01/26/2009 HMARZI2 0000009 504367 10541296

01 FC:2253 555.00 DA

76444/2204479.1